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Applicant: Kiyoshi MURAKAMI
Title: SUBSTRATE INSPECTING METHOD AND SUBSTRATE
INSPECTING APPARATUS USING THE METHOD
Application No.: 10/786,468
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Art Unit: 3729
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AMENDMENT AND REPLY UNDER 37 C.F.R. 1.312

Mail Stop ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This communication is being filed after receipt of a Notice of Allowance dated April 24, 2006, concerning the above-referenced patent application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 7 of this document.

Please amend the application as follows: